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Technical Sessions

Boston Park Plaza

Grand Ballroom A

Technical Session 1 – Controls and Mechatronics I

Session Co-chairs: David L. Trumper (Massachusetts Institute of Technology) and Lei Zhou (University of Wisconsin-Madison)

Wednesday, November 15, 2023

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- 1. Piezoelectric Wafer Stage Based on Highly Variable Viscoelastic Stiffness**
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Commercial Presentations: AMETEK Precitech Inc., Moore Nanotechnology Systems, LLC, Polytec, Inc., N. C. State University

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Session Co-chairs: Evan P. Mosier (Aerotech, Inc.) and Alexander H. Slocum (Massachusetts Institute of Technology)

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